

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/619,111	SHU ET AL.	
Examiner	Art Unit	
Binh X. Tran	1765	

SEARCHED					
Class	Subclass	Date	Examiner		
216	41	7/5/2005	BT		
216	42	7/5/2005	bT		
216	43	7/5/2005	BT		
216	48	7/5/2005	135		
216	75	7/5/2005	35		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
216	41	7/5/2005	か	
216	42	7/5/2005	45	
. 216	43	7/5/2005	か	
	6/48 6/75	7/5/2005	35	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Update search using US-PGPUB, USPAT, EPO, JPO, DERWENT, IBM_TBD databases	7/5/2005	<i>₿</i> 1		
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